

Message Text

CONFIDENTIAL

PAGE 01 STATE 118777
ORIGIN EB-07

INFO OCT-01 CIAE-00 COME-00 DODE-00 NSAE-00 USIA-06
TRSE-00 EUR-12 ERDA-05 ISO-00 /031 R

DRAFTED BY EB/ITP/EWT - RPRACHT:JAS
APPROVED BY EB/ITP/EWT - RPRACHT
COMMERCE/OEA - CSEASWORD
RPE

-----240421Z 016130 /17

R 232206Z MAY 77
FM SECSTATE WASHDC
TO USMISSION OECD PARIS

C O N F I D E N T I A L STATE 118777

EXCON

E.O. 11652: XGDS-1

TAGS: ESTC, COCOM, PL

SUBJECT: EXPORT OF POWER SEMICONDUCTOR MANUFACTURING
FACILITY TO POLAND -- IL 1355

REF: COCOM DOC (77) 309

REQUEST STATUS REPORT ON SUBJECT CASE. VANCE

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NNN

Message Attributes

Automatic Decaptioning: X
Capture Date: 01-Jan-1994 12:00:00 am
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: ENERGY, PROGRAMS (PROJECTS), INDUSTRIAL PLANTS
Control Number: n/a
Copy: SINGLE
Sent Date: 23-May-1977 12:00:00 am
Decaption Date: 01-Jan-1960 12:00:00 am
Decaption Note:
Disposition Action: RELEASED
Disposition Approved on Date:
Disposition Case Number: n/a
Disposition Comment: 25 YEAR REVIEW
Disposition Date: 22 May 2009
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1977STATE118777
Document Source: CORE
Document Unique ID: 00
Drafter: RPRACHT:JAS
Enclosure: n/a
Executive Order: X1
Errors: N/A
Expiration:
Film Number: D770184-0473
Format: TEL
From: STATE
Handling Restrictions: n/a
Image Path:
ISecure: 1
Legacy Key: link1977/newtext/t19770527/aaaaawzo.tel
Line Count: 40
Litigation Code IDs:
Litigation Codes:
Litigation History:
Locator: TEXT ON-LINE, ON MICROFILM
Message ID: 00a3bf8b-c288-dd11-92da-001cc4696bcc
Office: ORIGIN EB
Original Classification: CONFIDENTIAL
Original Handling Restrictions: n/a
Original Previous Classification: n/a
Original Previous Handling Restrictions: n/a
Page Count: 1
Previous Channel Indicators: n/a
Previous Classification: CONFIDENTIAL
Previous Handling Restrictions: n/a
Reference: n/a
Retention: 0
Review Action: RELEASED, APPROVED
Review Content Flags:
Review Date: 01-Mar-2005 12:00:00 am
Review Event:
Review Exemptions: n/a
Review Media Identifier:
Review Release Date: n/a
Review Release Event: n/a
Review Transfer Date:
Review Withdrawn Fields: n/a
SAS ID: 2402122
Secure: OPEN
Status: NATIVE
Subject: EXPORT OF POWER SEMICONDUCTOR MANUFACTURING FACILITY TO POLAND -- IL 1355
TAGS: ESTC, PL, COCOM
To: OECD PARIS
Type: TE
vdkgvwkey: odb://SAS/SAS.dbo.SAS_Docs/00a3bf8b-c288-dd11-92da-001cc4696bcc
Review Markings:
Margaret P. Grafeld
Declassified/Released
US Department of State
EO Systematic Review
22 May 2009
Markings: Margaret P. Grafeld Declassified/Released US Department of State EO Systematic Review 22 May 2009